

Amendments to the Claims:

This listing of claims will replace all prior versions, and listings, of claims in the application:

Listing of Claims:

1. (Currently Amended) A semiconductive film formed from obtained by feeding a resin composition comprising poly(ether ether ketone) and conductive carbon black having a DBP oil absorption within a range of 30 to 700 ml/100 g in a proportion of 5 to 40 parts by weight per 100 parts by weight of the poly(ether ether ketone) to an extruder, melt-extruding the resin composition in the form of a film from a die, the lip clearance of which has been controlled to at most 1.0 mm, and then cooling and solidifying the film in a molten state at a cooling temperature in a range of 60 to 120°C, wherein the semiconductive film has the following properties (a) to (c):

(a) the average value of its thickness being within a range of 30 to 250 μm , and the maximum value of the thickness being within a range of 1 to 1.2 times as much as the minimum value thereof,

(b) the average value of its volume resistivity being within a range of 1.0×10^2 to 1.0×10^{14} Ωcm , and the maximum value of the volume resistivity being within a range of 1 to 10 times as much as the minimum value thereof, and

(c) the number of reciprocating folds required up to cutting as determined by using a strip-like specimen having a width of 15 mm under conditions of a chuck bending angle of 135° right and left, a folding speed of 175 c/s and a load of 9.8 N per 100 μm of a thickness in accordance with "Testing Method for Folding Endurance by MIT Tester" as prescribed in JIS P 8115 being at least 10,000 times.

2. (Original) The semiconductive film according to claim 1, which further has property (d) that the tensile elongation at break in its any direction is at least 10% as measured by using a specimen having a width of 10 mm and a length of 100 mm under conditions of a crosshead speed of 50 mm/min and an interchuck interval of 50 mm by means of a tensile tester in accordance with JIS K 7113.

3. (Original) The semiconductive film according to claim 1, which further has property (e) that the modulus in tension in its any direction is at least 1.8 GPa as measured by using a specimen having a width of 10 mm and a length of 100 mm under conditions of a crosshead speed of 50

mm/min and an interchuck interval of 50 mm by means of a tensile tester in accordance with JIS K 7113.

4. (Original) The semiconductive film according to claim 1, which further has property (f) that a ratio (M/T) of tear strength (M) in the extruding direction (MD) of the film to tear strength (T) in a direction (TD) perpendicular to the extruding direction as determined in accordance with JIS K 6252 is within a range of 2/3 to 3/2.

5-7. (Cancelled)

8. (Previously Presented) The semiconductive film according to claim 1, wherein the conductive carbon black has a volatile matter content of at most 1.5% by weight.

9. (Previously Presented) The semiconductive film according to claim 1, wherein the conductive carbon black has a volume resistivity lower than $10^2 \Omega\text{cm}$.

10. (Previously Presented) The semiconductive film according to claim 1, wherein the conductive carbon black is acetylene black or oil furnace black or a mixture thereof.

11. (Previously Presented) A charge controlling member formed with the semiconductive film according to claim 1.

12. (Original) The charge controlling member according to claim 11, which is a semiconductive covered roller obtained by covering a roller base with a tube formed from the semiconductive film.

13. (Original) The charge controlling member according to claim 11, which is a semiconductive belt formed from the semiconductive film.

14-19. (Withdrawn)

20. (Previously Presented) The semiconductive film according to claim 1, wherein the conductive carbon black has a DBP oil absorption within a range of 100 to 400 ml/100g.

21. (Previously Presented) The semiconductive film according to claim 1, wherein the maximum value of the volume resistivity being within a range of 1 to 5 times as much as the minimum value thereof.

22. (Previously Presented) The semiconductive film according to claim 1, wherein the number of reciprocating folds is at least 20,000 times.

23. (New) The semiconductive film according to claim 1, wherein the semiconductor film is obtained by feeding the resin composition to the extruder, melt-extruding the resin composition in

the form of a film from the die, the lip clearance of which has been controlled to at most 1.0 mm, and then cooling and solidifying the film in a molten state by a cooling temperature in a range of 70 to 100°C.

24. (New) The semiconductive film according to claim 1, wherein the semiconductor film is obtained by feeding the resin composition to the extruder, melt-extruding the resin composition in the form of a film from the die, the lip clearance of which has been controlled to at most 1.0 mm, and then cooling and solidifying the film in a molten state by a cooling temperature in a range of 80 to 90°C.